



# ENBIS-22 Trondheim Conference

## Tuesday, June 28, 2022

### CONTRIBUTED Process 2 - EL5 (11:30 AM - 12:30 PM)

-Conveners: Alessandro Di Bucchianico

time	[id] title	presenter
11:30 AM	[31] R2R Control of a Chemical-Mechanical-Polishing Process Based on Machine Learning Techniques	TERRAS, Lucile
11:50 AM	[32] Multivariate data analysis for faster root cause identification in semiconductor industry	RABHI, Ilham
12:10 PM	[117] Methods for variable time-delay estimation in industrial data	CATTALDO, Marco